

Notice of References Cited	Application/Control No. 10/718,881	Applicant(s)/Patent Under Reexamination CHENG ET AL.	
	Examiner Thanh T. Nguyen	Art Unit 2813	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
X	A	US-6,617,232	09-2003	Kim et al.	438/597
X	B	US-6,849,562	02-2005	Lang et al.	438/778
X	C	US-6,174,810	01-2001	Islam et al.	438/687
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	E	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

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	N					
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Wolf et al. "silicon processing for the VLSI Era" 1986, vol. 1, pages 182-195, 551-555, 581-582.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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